

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

JIN-XING LI ET AL.

Serial No.: 10/528,765

Filed: December 1, 2006

For: TWO LAYER LTO TEMPERATURE OXIDE  
CKSIDE SEAL FOR A WAFER

Attorney Docket No.: WSAG 0107 PUSA

Group Art Unit: 1794

Examiner: Jonathan C. Langman

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
U.S. Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed November 23, 2010, please amend the above-identified application as follows: